



PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Docket No: Q79054

Masashi OTSUKI, et al.

Appln. No.: 10/758,130

Group Art Unit: 1754

Confirmation No.: 5017

Examiner: Ngoc Yen M. Nguyen

Filed: January 16, 2004

For: SILICON CARBIDE POWDER AND METHOD FOR PRODUCING THE SAME

**PETITION FOR EXTENSION OF TIME UNDER 37 C.F.R. § 1.136**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

Pursuant to 37 C.F.R. § 1.136, Applicant hereby petitions for an extension of time of two months, extending the time for responding to the Office Action of June 3, 2005, to November 3, 2005.

A check for the statutory fee of \$450.00 is attached. The USPTO is directed and authorized to charge all required fees, except for the Issue Fee and the Publication Fee, to Deposit Account No. 19-4880. Please also credit any overpayments to said Deposit Account. A duplicate copy of this sheet is enclosed.

Respectfully submitted,

Fang Liu  
Registration No. 51,283

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Date: November 3, 2005